

#16 / Amnd D HE
5/24/02

REPLY UNDER 37 CFR 1.116
EXPEDITED PROCEDURE
EXAMINING GROUP 2815

ATTORNEY'S DOCKET No. 042390.P7068

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE THE
 APPLICATION OF: Peng Cheng et al.
 APPLICATION NO.: 09/343,293
 ORIGINALLY FILED: June 30, 1999
 CPA FILED: July 30, 2001
 TITLE: TRANSISTOR STRUCTURE
 HAVING SILICIDE
 SOURCE/DRAIN
 EXTENSIONS

ART UNIT: 2815
 EXAMINER: Edgardo Ortiz

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APR 4 2002

TECHNOLOGY CENTER 2800

RESPONSE TO FINAL OFFICE ACTION

The Commissioner for Patents
BOX AF
 Washington, D.C. 20231

The following amendments and remarks are respectfully submitted in response to the Final Office Action having a mailing date of March 19, 2002 ("Final Office Action").

I, Shenise Ramdeen, hereby certify that this correspondence is being facsimile transmitted to the U.S. Patent and Trademark Office on April 4, 2002.

Shenise Ramdeen

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